

Butuzov Vladimir A. Course Schedule

TUESDAY

08:30 — 10:05	■ LEC	Automated Design Systems in Microelectronics	👥 S21-402	📍 D-405
10:15 — 11:50	▣ SEM	Automated Design Systems in Microelectronics	👥 S21-402	📍 D-405
	▣ LAB	Automated Design Systems in Microelectronics	👥 S21-402	📍 K-306
13:35 — 16:05	■ LEC	Electromagnetic Compatibility (Emc) (2024-09-03 — 2024-09-17)	👥 M24-423	📍 D-405
	■ SEM	Electromagnetic Compatibility (Emc) (2024-09-24 — 2024-12-03)	👥 M24-423	📍 D-405

FRIDAY

13:35 — 15:15	■ PR	Practical Training (Research Work) (2024-09-06 — 2024-12-06)	👥 M23-423	📍 dep.27
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